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Substitute for form 1449/PTO

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**


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**Complete if Known**

Application Number	to be assigned
Filing Date	January 29, 2004
First Named Inventor	M. Nakasuji
Art Unit	to be assigned
Examiner Name	to be assigned
Attorney Docket Number	011470A

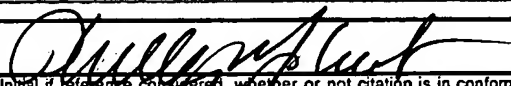
Sheet 1 of 2

**U. S. PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
		US- 6,125,522	10/3/00	Nakasuji	
		US- 6,087,667	7/11/00	Nakasuji, et al.	
		US- 5,981,947	11/9/99	Nakasuji, et al.	
		US- 5,892,224	4/6/99	Nakasuji	
		US- 5,359,197	10/25/94	Komatsu, et al.	
		US- 4,912,052	3/27/90	Miyoshi, et al.	
		US- 4,726,689	2/23/88	Pollock	
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**FOREIGN PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> (if known)				

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10-8-04

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Sheet	2	of	2	Attorney Docket Number	011470A

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
cy	1	Sandland; "An Electron-beam inspection system for x-ray mask production", J. of Vacuum Sci & Tech.B (1991) Vol. 9, No. 6; pp3005-3009	
cy	2	Meisburger et al; "Requirements and performance of an electron-beam column designed for x-ray mask inspection"; J. of Vacuum Sci & Tech.B (1991) Vol. 9, No. 6; pp 3010-3014	
cy	3	Lischke et al; "Multi-beam concepts for Nanometer Devices"; JP J. Applied Physics (1989) Vol. 28, pp 2058-64.	
cy	4	Electron/Ion Beam Handbook 2nd; Nikkan Kogyo (1988) pp 115-119 (with partial English Translation).	
cy	5	U.S. Patent Application S.N. 09/985,323; filed 11/2/2001; Mamoru Nakasuji et al; "Electron Beam Apparatus and Device Production Method Using the Electron Beam Apparatus"	
cy	6	U.S. Patent Application S.N. 09/985,324; filed 11/2/2001; Toshifumi Kimba et al; "Apparatus for Inspecting Material with Electron Beam, Method for Operating Same, and ..."	
cy	7	U.S. Patent Application S.N. 09/985,325; filed 11/2/2001; Mamoru Nakasuji et al; "Electron Beam Apparatus and Method of Manufacturing Semiconductor Device Using the ..."	
cy	8	U.S. Patent Application S.N. 09/985,331; filed 11/2/2001; Mamoru Nakasuji et al; "Method for Inspecting Substrate, Substrate Inspecting System and Electron Beam Apparatus"	

Examiner Signature		Date Considered	10-8-04
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